Electronic Patent Application Fee Transmittal							
Application Number:	10658460						
Filing Date:	10-Sep-2003						
Title of Invention:	Bias sputtering film forming process and bias sputtering film forming apparatus						
First Named Inventor/Applicant Name:	Myounggoo Lee						
Filer:	Tarik Nabi/Wendy Barrow						
Attorney Docket Number:	029567-00004						
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Utility under 35 USC 111(a) Filing Fees							
Description		Fee Code	Quantity	Amount	Sub-Total in USD(\$)		
Basic Filing:							
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Claims:							
Miscellaneous-Filing:							
Petition:							
Patent-Appeals-and-Interference:							
Post-Allowance-and-Post-Issuance:							
Extension-of-Time:							
Extension - 3 months with \$0 paid		1253	1	1110	1110		

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
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